

Docket No.: 214814US0

Image Rec 1731
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Naomichi MIYAKAWA

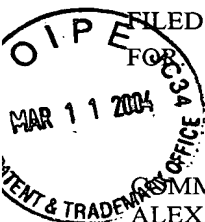
SERIAL NO: 09/975,262

GAU: 1731

FILED: October 12, 2001

EXAMINER: FIORILLA, C.

METHOD FOR PRODUCING A SILICON NITRIDE FILTER



REQUEST FOR CONTINUED EXAMINATION (RCE) TRANSMITTAL

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

This is a request for Continued Examination (RCE) under 37 C.F.R. §1.114 of the above-identified application.

Submission required under 37 C.F.R. §1.114

Previously Submitted:

- ☐ Consider the amendment(s)/reply under 37 C.F.R. §1.116 previously filed on
- ☐ Consider the arguments in the Appeal Brief or Reply Brief previously filed on

Enclosed:

- ☒ Amendment under 37 CFR 1.114/Reply
- ☐ Information Disclosure Statement (IDS)
- ☐ Other:

FEES	RATE	CALCULATIONS
<input type="checkbox"/> Suspension of action on the above-identified application is requested under 37 C.F.R. §1.103(c) for a period of months.	\$130.00	\$0.00
<input checked="" type="checkbox"/> RCE Fee required under 37 C.F.R. §1.17(e)	\$770.00	\$770.00
<input type="checkbox"/>		\$0.00
<input type="checkbox"/>		\$0.00
TOTAL OF ABOVE CALCULATIONS:		\$770.00
<input type="checkbox"/> REDUCTION BY 50% FOR FILING AS SMALL ENTITY		\$0.00
TOTAL:		\$770.00

- ☒ A check in the amount of \$770.00 is enclosed
- ☐ Credit card payment form is attached to cover the fees in the amount of \$0.00
- ☒ Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- ☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 CFR 1.136, and any additional fees required under 37 CFR 1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate of this sheet is enclosed.

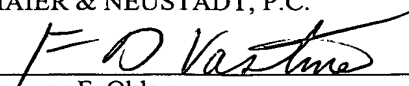
03/12/2004 JADD01 00000026 09975262

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Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.


Norman F. Oblon

Registration No. 24,618

Customer Number

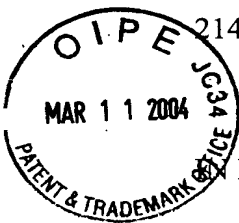
22850

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Registration No. 27,013

Appln. No. 09/975,262
Amendment under 37 CFR 1.114



214814US0

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RE APPLICATION OF:

:

Naomichi MIYAKAWA

: GROUP ART UNIT: 1731

SERIAL NO.: 09/975,262

:

FILED: OCTOBER 12, 2001

: EXAMINER: FIORILLA, C.

FOR: METHOD FOR PRODUCING A
SILICON NITRIDE FILTER

AMENDMENT UNDER 37 CFR 1.114

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In advance of consideration on the merits, please amend the above-identified application as follows.

Amendments to the claims begin on page 2 of this paper.

Remarks/comments begin on page 7 of this paper.